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APPLICANTS

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** CONTINUING DATA *****

** FOREIGN APPLICATIONS ***** *Yes.*
 JAPAN 2003-011017 01/20/2003

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
 ** 04/13/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>[Signature]</i> Examiner's Signature Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWING 12	TOTAL CLAIMS 12	INDEPENDENT CLAIMS 2
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TITLE

Semiconductor substrate, method for fabricating the same, and method for fabricating semiconductor device

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